

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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Title of Invention

MULTI-LAYER INTEGRATED SEMICONDUCTOR
STRUCTURE

Application Number : 10/655854
Confirmation Number: 7254
First Named Applicant: Rafael Reif
Attorney Docket Number: MIT-136AUS
Art Unit: 2811
Examiner:
Search string: (5523628 or 6717244).pn



US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5523628	1996-06-04	Williams et al.			
	2	6717244	2004-04-06	Hikita et al.			

Signature

Examiner Name	Date